

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of )  
 Tadahiro OHMI et al. ) Group:  
 Serial No.: )  
 Filed: July 13, 2001 ) Examiner:  
 Title: METAL MATERIAL HAVING FORMED THEREON )  
 CHROMIUM OXIDE PASSIVE FILM AND METHOD )  
 FOR PRODUCING THE SAME, AND PARTS )  
 CONTACTING WITH FLUID AND SYSTEM FOR )  
 SUPPLYING FLUID AND EXHAUSTING GAS )

PRELIMINARY AMENDMENT

Hon. Commissioner of Patents and Trademarks  
 Washington, D.C. 20231

Sir:

Applicant hereby submits the following Amendment.

IN THE CLAIMS

1. (Amended) Metallic material provided with a chromium-oxide passivation film comprising a passivation film consisting of chromium oxide obtained by oxidizing a chromium coat on the metallic material of which surface roughness (Ra) is not more than [1.5im] 1.5 $\mu$ m.

2. (Amended) The metallic material provided with the chromium-oxide passivation film according to claim 1, said film having pin holes wherein pin holes of said chromium-oxide passivation film are filled.

3. (Amended) A method for manufacturing metallic material on which a chromium-oxide passivation film is formed, comprising the step of: